

# Organic Thin Film Deposition System for DEAP-3600

Ben Broerman

Queen's University

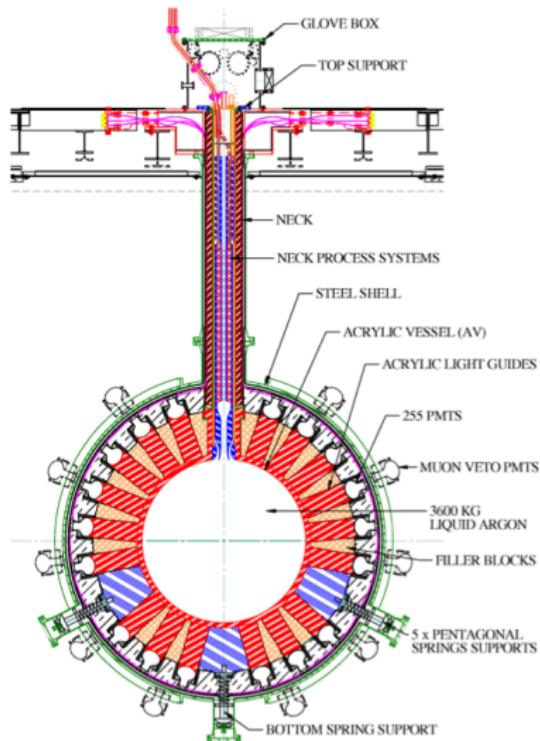
18 June 2014



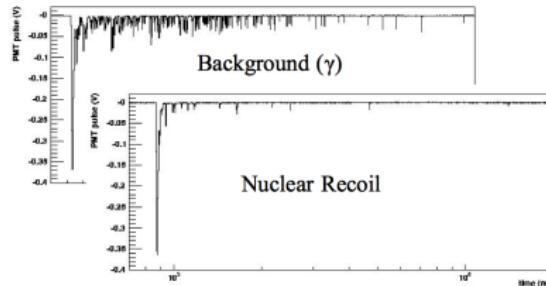
# Outline

- DEAP-3600 Dark Matter Experiment
- Wavelength Shifter tetraphenyl butadiene (TPB)
- Deposition System
  - Deposition Source
  - Deployment System
  - Instrumentation
  - Simulation
- Summary and Outlook

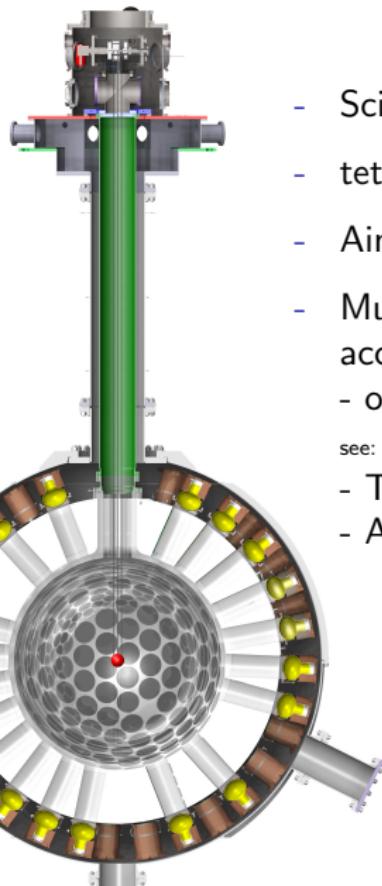
# Dark Matter Experiment using Argon Pulse-shape Discrimination



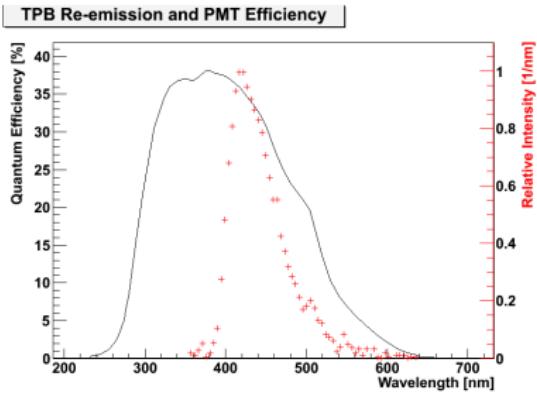
- 3600kg single phase liquid argon (1000kg fiducial)
- Under construction at SNOLAB: 6000 m.w.e.
- Dark matter search with SI sensitivity:  $10^{-46} \text{ cm}^2$  for 100 GeV WIMP
- Pulse-shape discrimination
  - 2 argon dimer states:  $\tau_1 = 6\text{ns}$ ,  $\tau_3 = 1.6\mu\text{s}$
  - discriminate  $\beta/\gamma$  vs. n.r.



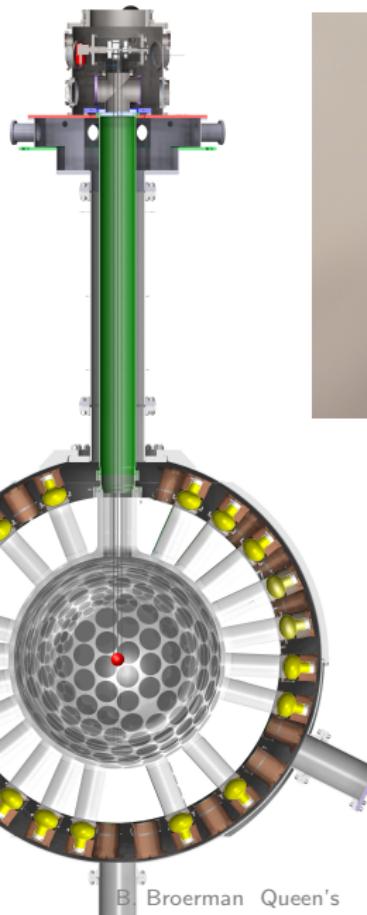
# Wavelength Shifting & Deposition Overview



- Scintillation from  $Ar_2^*$  or  $Ar_2^+$  dimers produces 128nm  $\gamma$
  - tetraphenyl butadiene (TPB) shifts to peak 430nm
  - Aim to deposit  $1\mu m$  TPB coating over AV interior ( $10m^2$ ).
  - Multi-purpose deployment system provides entry into the AV accommodating:
    - optical calibration sources (LED Ball, Laser Ball)
- see: DEAP-3600 Optical Calibration Systems poster
- TPB deposition source
  - AV bakeout heating source

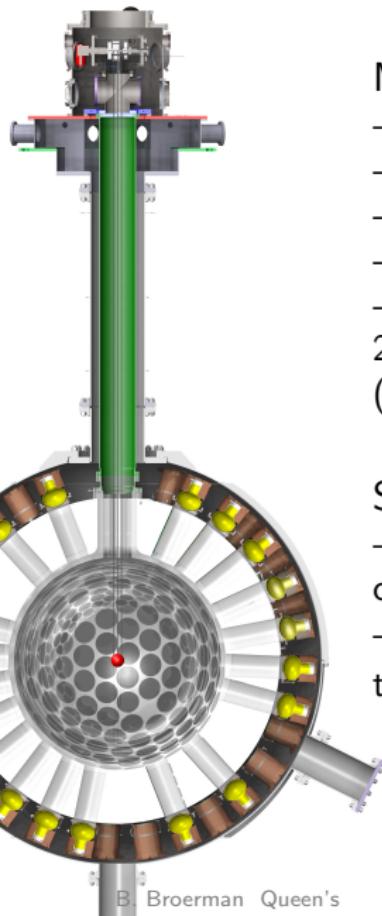


# Deposition Source



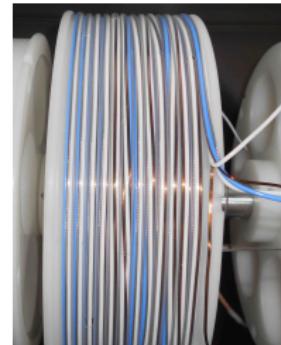
- 11cm dia. spherical source
- Exterior SS sheathed Nichrome wire
- Inner copper crucible holds TPB
- Instrumented w/ temperature sensors
- Aluminum prototype source tested
- SS source in manufacturing - controlled radiopurity

# Cable and Stage



## Main Cable Bundle

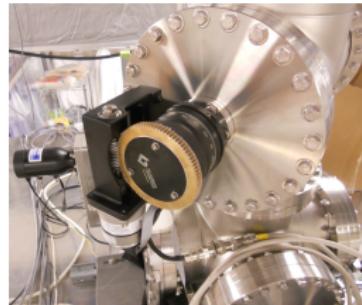
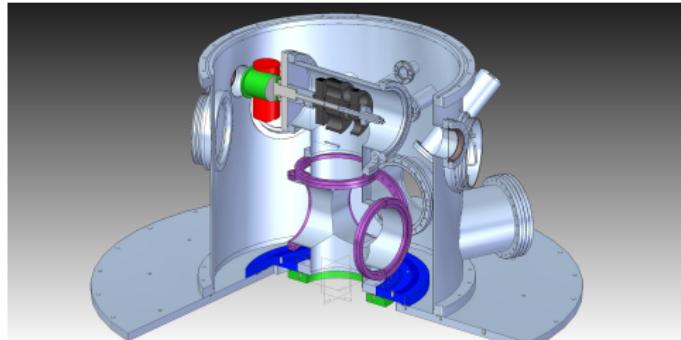
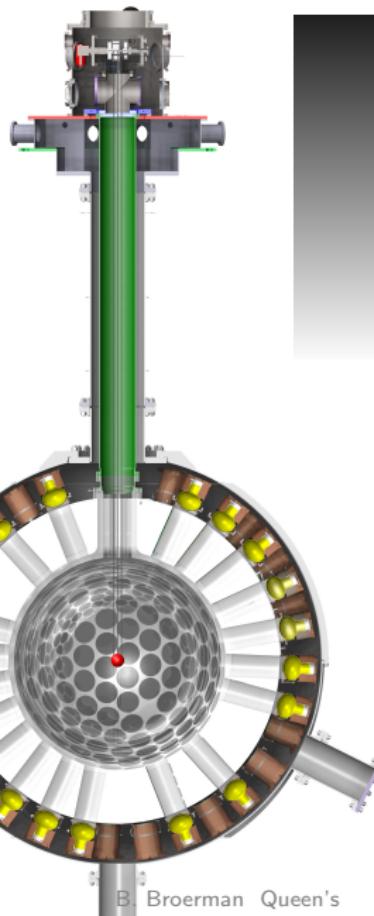
- 1 SS structural member
  - 2 power cables
  - 1 coax (LED triggering)
  - 2 4-wire thermocouple cable
  - Encased in 1' sections of teflon tubing
- 2 additional coax cables offer stability and affix to stage (IR probe/ deposition monitor connections)



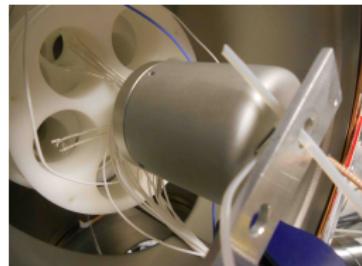
## Stage

- Deployed to base of neck to prevent extraneous TPB coating
- Mounting for deposition monitor, IR probe, support lines, target for laser distance gauge

# Deployment System

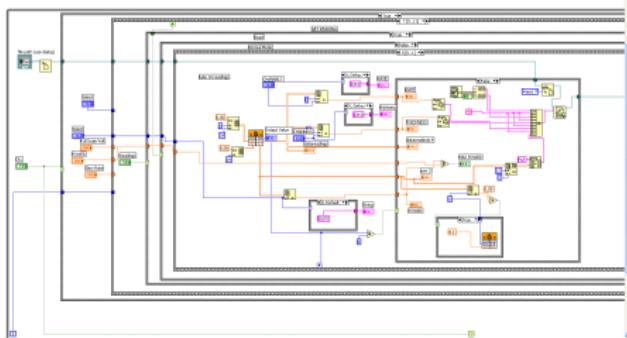


- McLennan Sim-Step Motor
- Main deployment bobbin, 2 tuned secondary bobbins.
- Coax slip ring: LED triggering and deposition monitor
- 14 wire fixed slip ring: control, heater, RTD sensors
- Laser Distance gauge

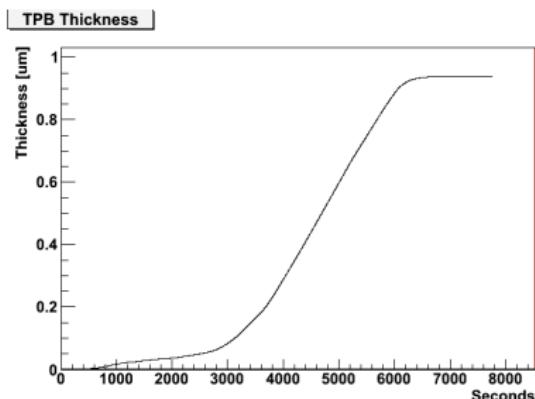
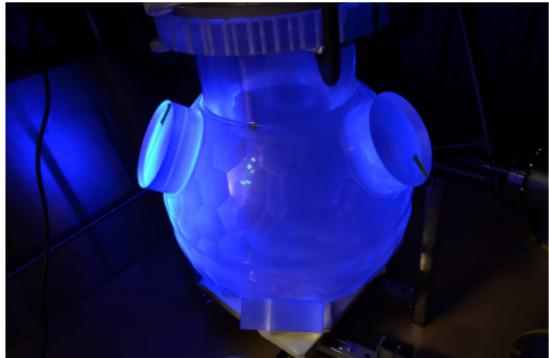


# Sensors and Control

- Direct Thickness Measurement: quartz deposition monitor
- Source temperature control: 2 RTDs
- Acrylic surface temperature: IR probe
- Motor control through McTerminal
- Power/temperature/position logging in LabView

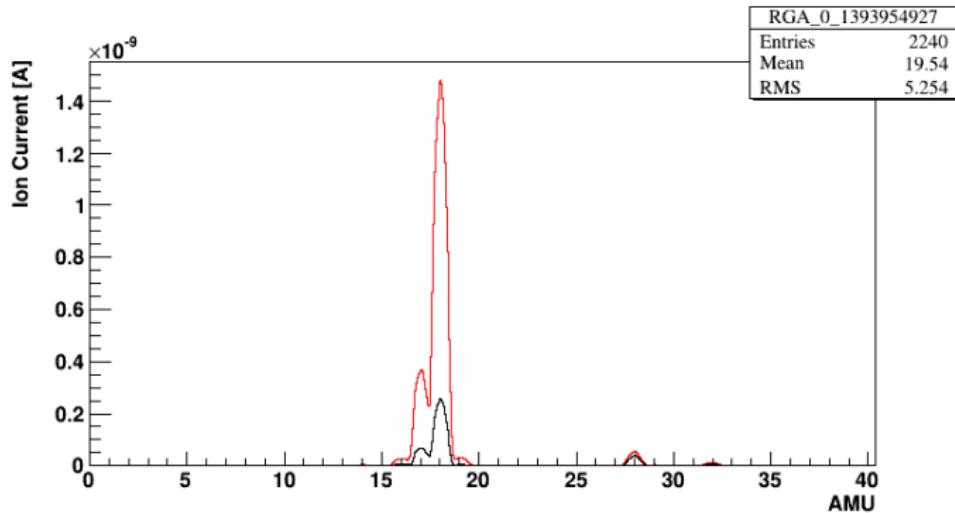


# 20" Test Vessel



# AV Bakeout

- During resurfacing, AV is rinsed with water.
- Perform vacuum bake out of AV, heating inner acrylic surface to 60°C.
- Monitor outgassing w/ Cirrus RGA.

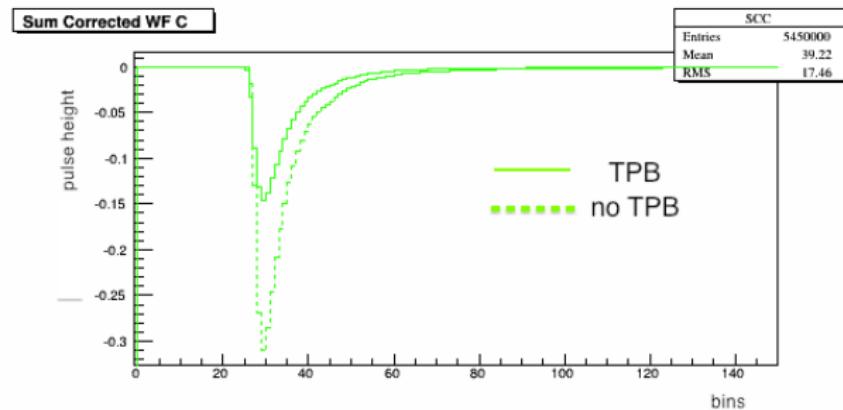


RGA spectrum from bakeout of 20" test vessel

# Thickness Monitoring

- Deposition monitor provides single sample point of TPB thickness
  - expect uniform distribution, but attempt to map uniformity
- Install LED's on evaporation source
- Flash during TPB deposition
- Monitor light attenuation vs. thickness.

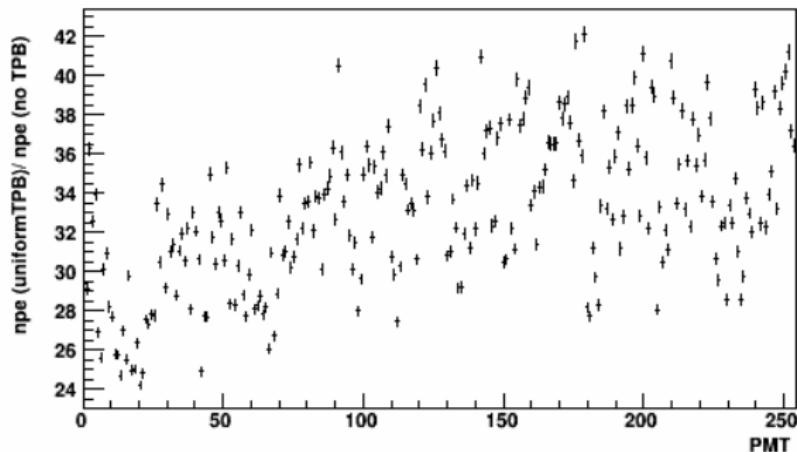
- Intensity highly dependent on LED orientation.



## Simulation

- Require TPB thickness non-uniformity to be less than 15%.
- Simulation of uniform and non-uniform (top hemisphere thicker) geometries.

Expected number photoelectrons per pmt for uniform TPB coating vs. no TPB coating:



## Summary and Outlook

- Wavelength shifting required to view scintillation in argon
- Deposit  $1\mu\text{m}$  tetraphenyl butadiene over inner AV surface.
- Current deposition source tested on small scale.
- Deployment system tested.
- Continued exercising of full system/ test TPB deposition.
- Deposition late July/August.

# DEAP Collaboration



University of Alberta **D. Grant**, P. Gorel, **A. Hallin**, J. Soukup, C. Ng, B. Beltran, J. Tang, K. Olsen, R.

Chouinard, T. McElroy, S. Crothers, S. Liu, P. Davis, A. Vinagreiro

Carleton University **K. Graham**, C. Ouellet, C. Brown

Queen's University D. Bearse, J. Bonatt, **M. Boulay**, B. Broerman, B. Cai, **M. Chen**, K. Dering, S.

Florian, R. Gagnon, P. Giampa, V.V. Golovko, P. Harvey, M. Kuźniak, J.J. Lidgard,

**A. McDonald**, C. Nantais, **A.J. Noble**, E. O'Dwyer, P. Pasuthip, **W. Rau**, P.

Skensved, T. Sonley, L. Veloce, M. Ward

SNOLAB/Laurentian **B. Cleveland**, **F. Duncan**, **R. Ford**, **C.J. Jillings**, T. Pollmann

SNOLAB I. Lawson, K. McFarlane, P. Liimatainen, O. Li, E. Vázquez-Jáuregui

TRIUMF **F. Retiere**, A. Muir, P. A. Amaudruz, D. Bishop, S. Chan, C. Lim, C. Ohlmann, K.

Olchanski, V. Strickland

RAL **P. Majewski**, R. Shah

RHUL A. Butcher, E. Grace, R. Guenette, **J. Monroe**, J. Walding, M. Widorski

University of Sussex S. Churchwell, T. Bromwich, **S. J. M. Peeters**